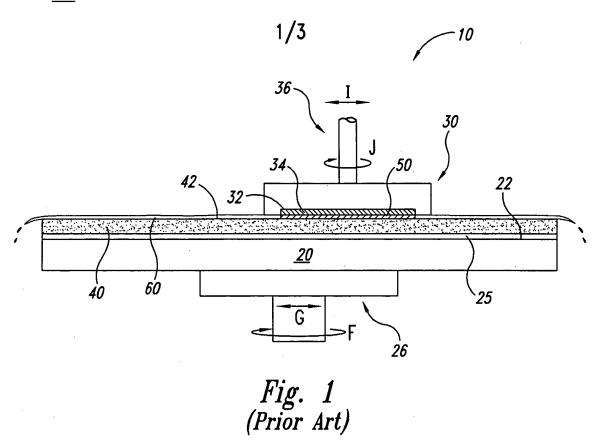
Atty Docket: 10829-8724US <u>Inventors</u>: Taylor et al.

<u>Title</u>: METHODS FOR REMOVING DOPED POLYSILICON FROM MICROFEATURE WORKPIECES



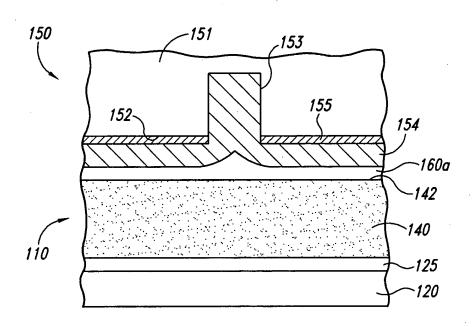


Fig. 2

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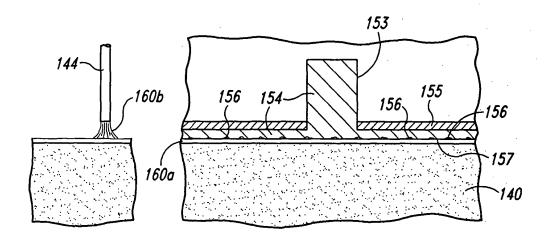


Fig. 3

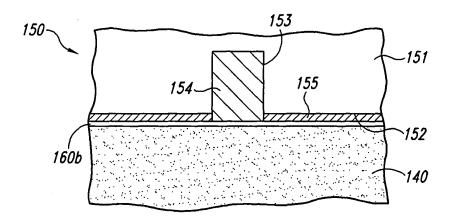


Fig. 4

